



EXPRESS MAIL NO.: EV 346 794 035 US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bruno GHYSELEN et al.

Confirmation No. 9064

Application No: 10/637,094

Group Art Unit: 2812

Filing Date: August 6, 2003

Examiner: Thanh V. Pham

For: METHOD AND APPARATUS FOR
ADJUSTING THE THICKNESS OF A LAYER
OF SEMICONDUCTOR MATERIAL

Atty. Docket No.: 4717-6300

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This communication responds to the Advisory Action dated September 19, 2005, concerning the above-identified application.

Amendments to the claims begin on page 2.

Remarks begin on page 7 of this paper.

A Request for Continued Examination is enclosed.

A petition for an extension of time for one additional month from September 3, 2005 to October 3, 2005 is filed concurrently herewith. No additional fee is believed due with this Amendment. Please charge any fee deemed necessary to Winston & Strawn LLP Deposit Account No. 50-1814.